

Notice of References Cited	Application/Control No. 10/657,495	Applicant(s)/Patent Under Reexamination LAI, YU-CHIN	
	Examiner Helen L. Pezzuto	Art Unit 1713	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,878,792	04-2005	Ichinohe, Takashi	528/28
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stiller et al. Proceeding of SPIE (2003), 5122, 173-178.
	V	Sabi et al. Japanese Journal of Applied Physics, Part I: (2001), 40(3B), 1613-1618.
	W	Adameck et al. Applied Physics Letters (1998), 73(20), 2884-2886. □□
	X	Hill et al. Journal of Applied Physics (1991), 70(8), 4649-51.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.